



Docket No.: 49657-871

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of
Masahiko TAKEUCHI, et al.

Serial No.: 09/725,853

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Group Art Unit: 2823

Filed: November 30, 2000

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Examiner: J.A. Garcia

For: PHOTOMASK INCLUDING AUXILIARY MARK AREA, SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

#5
Electron
J. M. Amador
6/12/03

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of May 21, 2003 wherein restriction has been required, Applicant(s) hereby elect Group I (claims 1-13) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: June 10, 2003

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